



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Chen, et al.

Serial No.: 10/611,589

Confirmation No.: 5241

Filed: June 30, 2003

For: Method and Apparatus for
Annealing Copper Films

§ Group Art Unit: 1742

§ Examiner: Unknown

MAIL STOP PGPUB DRAWINGS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

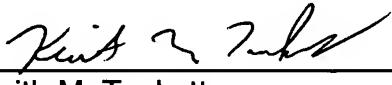
CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>12/15</u> , 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop PGPUB Drawings, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.	
<u>12/15/03</u>	<u>Keith M. Tackett</u>
Date	Signature

SUBMISSION OF FORMAL DRAWINGS

Attached please find (8) sheets of formal drawings, with gummed labels identifying the application for which they are submitted. The Examiner is requested to substitute these formal drawings for the informal drawings used during the prosecution of the subject patent application.

Any comparison fee should be charged to Deposit Account No. 20-0782/AMAT/1717.D2/KMT. Two copies of this document are enclosed for your convenience. If any additional informalities are identified by the Examiner, please contact the undersigned attorney at (713) 623-4844.

Respectfully submitted,


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